



Docket No.: T0461.70041US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Stefan Marinca et al.
Serial No.: 10/680,265
Confirmation No.: 6382
Filed: October 7, 2003
For: METHOD AND APPARATUS FOR COMPENSATING FOR
TEMPERATURE DRIFT IN SEMICONDUCTOR PROCESSES AND
CIRCUITRY
Examiner: Y. Rossoshek
Art Unit: 2825

Certificate of Mailing Under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: February 22, 2007


Steven J. Henry, Registration No. 27,900

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

INTRODUCTORY COMMENTS

In response to the Office Action dated September 6, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Drawings begin on page 2 of this amendment.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.